



1FW
PATENT
81788.0263

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Akira Tanaka, et al.

Serial No: 10/724,570

Confirmation No.: 8635

Filed: November 26, 2003

For: SEMICONDUCTOR LASER ELEMENT,
METHOD FOR FABRICATION THEREOF,
AND MULTI-WAVELENGTH
MONOLITHIC SEMICONDUCTOR LASER
DEVICE

Art Unit: 2828

Examiner: Tod Thomas Van Roy

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to:
Mail Stop Amendment, Commissioner for Patents,
P.O. Box 1450
Alexandria, VA 22313-1450, on
November 3, 2005
Date of Deposit
William H. Wright
Name
William H. Wright
Signature
November 3, 2005
Date

ELECTION

Mail Stop AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

This is in response to the Restriction Requirement dated October 14, 2005. Applicant elects for continued prosecution the species of FIGS. 1-3. Applicant submits that claims 1-18 are readable on the elected species. This election is made without traverse.

Action on the merits is respectfully requested.

Respectfully submitted,

HOGAN & HARTSON L.L.P.

By: William H. Wright

William H. Wright
Registration No. 36,312
Attorney for Applicant(s)

500 South Grand Avenue, Suite 1900
Los Angeles, California 90071
Phone: 213-337-6700
Fax: 213-337-6701